

# Notice of References Cited

Application No.

10-060569

Applicant(s)

Kobayashi

Examiner

George Goudreau

Group Art Unit

1763

Page 1 of 1

## U.S. PATENT DOCUMENTS

*	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A	5,972,179	10-26-99	Chittipeddi et. al	204	192.17
B	5,714,804	2-3-98	Miller et. al.	253	763
C	5,793,113	8-11-98	Oda	257	774
D	5,656,545	8-12-97	Yu	438	627
E					
F					
G					
H					
I					
J					
K					
L					
M					

## FOREIGN PATENT DOCUMENTS

*	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N						
O						
P						
Q						
R						
S						
T						

## NON-PATENT DOCUMENTS

*	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
U	"Advanced PVD Ti/TiN Liners For Contact And Via Applications"; Barth et. al., SPIE, vol. 3214, pp. 2-12; (1997)	
W		
X		

\* A copy of this reference is not being furnished with this Office action.  
(See Manual of Patent Examining Procedure, Section 707.05(a).)